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	Filing Date		2006-03-27	
	First Named Inventor	VAN GEEST		
	Art Unit			
	Examiner Name			
Attorney Docket Number		NL031170U1		

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/JHN/	2	5574836		1996-11-12	BROEMMELSIEK, R.	
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	2	BISHOP, M. "EFFICIENT RECONSTRUCTION TECHNIQUES FOR POST-RENDERING 3D IMAGE WARPING"; UNC CS TECHNICAL REPORT, MARCH 21, 1998, PP. 1- 14, XP002312619.	<input type="checkbox"/>
	3	FEHN ET AL "3D ANALYSIS AND IMAGE-BASED RENDERING FOR IMMERSIVE TV APPLICATIONS"; SIGNAL PROCESSING, IMAGE COMMUNICATION, ELSEVIER SCIENCE PUBLISHERS, AMSTERDAM, NL., VOL. 17, NO. 9, OCTOBER 2002, PP. 705-715, XP004388881.	<input type="checkbox"/>
	4	CHEN ET AL: "VIEW INTERPOLATION FOR IMAGE SYNTHESIS", COMPUTER GRAPHICS ANNUAL CONFERENCE SERIES, PROCEEDINGS OF SIGGRAPH 93, PP. 279-288. 1993	<input type="checkbox"/>
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